"Method of Detecting a Polishing End Point in a Chemical Mechanical Polishing Process" Hyung Jun KIM Appl. No.: NEW - Atty. Docket: 29936/39457

FIG. 1

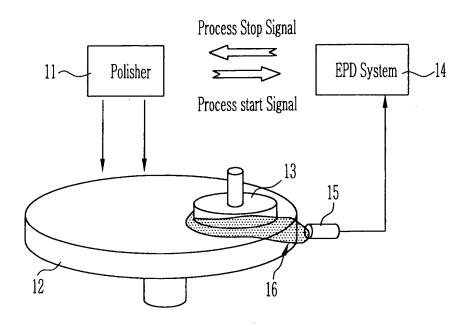
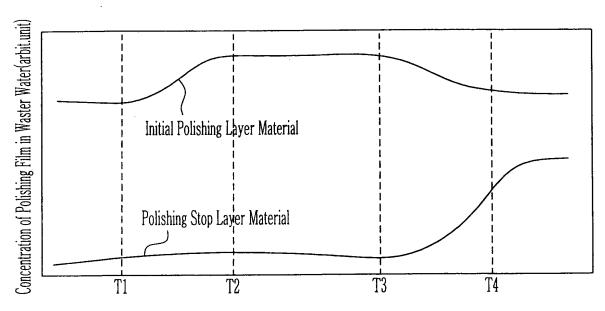


FIG. 3



"Method of Detecting a Polishing End Point in a Chemical Mechanical Polishing Process" Hyung Jun KIM Appl. No.: NEW - Atty. Docket: 29936/39457

